Notice of References Cited Application/Control No. 10/577,014 Examiner RANDOLPH CHU Applicant(s)/Patent Under Reexamination SANO, HISASHI Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2009/0046179	02-2009	Aoyama et al.	348/241
*	В	US-7,565,044	07-2009	Akahoshi et al.	385/16
	O	US-			
	ם	US-			
	ш	US-			
	F	US-			
	O	US-			
	Ι	US-	- 15		
	Ι	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	WO2004/019607	03-2004	Japan	Aoyama et ak	H04 5/232
	0					
	Р					
	Q					
4	R					
	s					
	I			2-12-3-6	100	

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	x	

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